



PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/712,775 Group Art Unit: 1765
Filing Date: November 14, 2003 Examiner: Anita K. Alanko
Applicant: Donggyun Han et al.
Title: APPARATUS AND METHOD FOR REMOVING
PHOTORESIST FROM A SUBSTRATE
Attorney Docket: 2557-000216/US

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop Amendment

July 17, 2006

AMENDMENT

Sir:

In response to the Office Action mailed March 17, 2006, the due date having been extended one (1) month to July 17, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims begin on page 2 of this Amendment.

Remarks begin on page 8 of this Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	40	-	50	=	0
Independent	3	-	4	=	0

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